



1FW
2823
PATENT

Customer No. 23,494
Attorney Docket No. TI-31133
Application No.: 10/001,483

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Antonio ROTONDARO) Group Art Unit: 2823
Application No.: 10/001,483) Examiner: Michelle Estrada
Filed: November 1, 2001)
For: METHOD TO IMPROVE THE)
UNIFORMITY AND REDUCE THE)
SURFACE ROUGHNESS OF THE)
SILICON DIELECTRIC)
INTERFACE)

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office
Action of January 16, 2004 (May 16, 2004, being a Sunday).

Please grant any extensions of time required to enter this response and charge
this and any additional required fees to the Texas Instruments Deposit Account 20-
0668.

Respectfully submitted,

Dated: May 17, 2004

By: Jonathan A. Hack for
Jonathan A. Hack
Reg. No. 47,623

Reg A 42,672